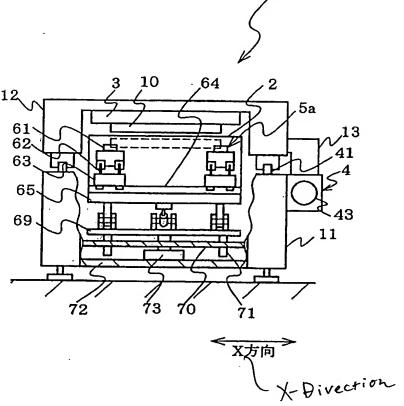
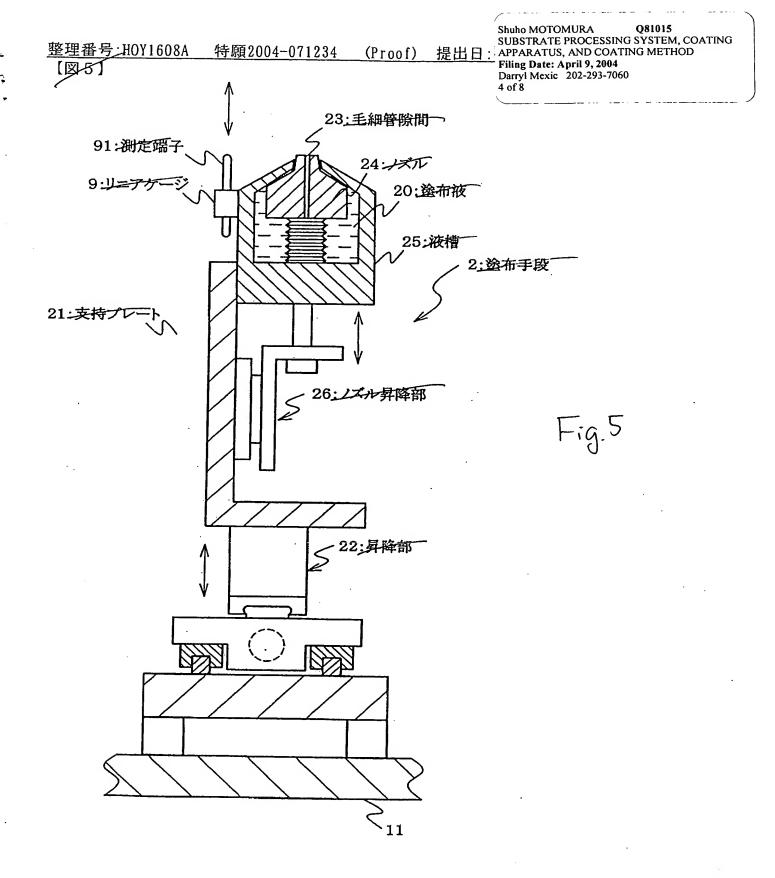


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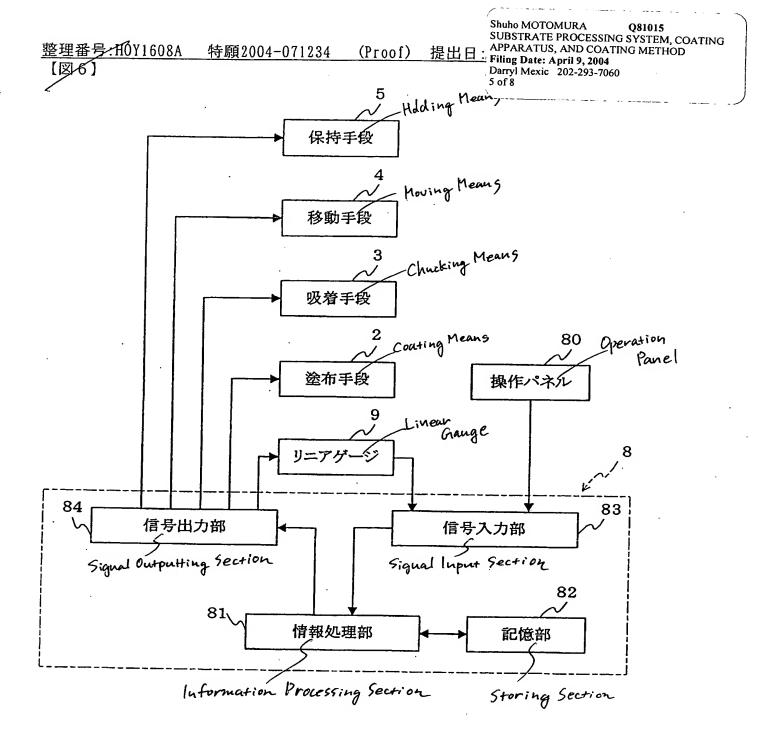


Fig.6

Shuho MOTOMURA Q81015
SUBSTRATE PROCESSING SYSTEM, COATING APPARATUS, AND COATING METHOD
Filing Date: April 9, 2004
Darryl Mexic 202-293-7060 整理番号:HOY1608A 特願2004-071234 (Proof) Jズルの原点位置G2 Original Position of Nozzle GZ (突出状態位置) 20 Original Position of Linear Gauge Withdrew State

Jストの Position of Nozzle

収納状態位置 リニアケーシの 原点位置G3 液槽の原点位置G1 -Original Position
of Liquid Tank 61 Fig.7

